

Beam-based optimization at PAL-XFEL

to maximize FEL intensity

Chi Hyun Shim

on behalf of XFEL Accelerator Department



포항가속기연구소
POHANG ACCELERATOR LABORATORY

Outline

- **Introduction of PAL-XFEL**
- **Optimization with uncompressed electron beam**
 - Beam-based alignment for undulator line
 - Undulator offset alignment / undulator gap alignment
- **Optimization with compressed electron beam (~ 3 kA)**
 - Lattice matching for linac and undulator line
 - Undulator tapering / phase shifter gap tuning
- **Summary**

Operation History of PAL-XFEL



Apr. 2011: PAL-XFEL project started

Apr. 2016: Commissioning started

Jun. 2017: User-service started
- 120 days for user (95% of availability)

2018: 140 days for user (95% of availability)

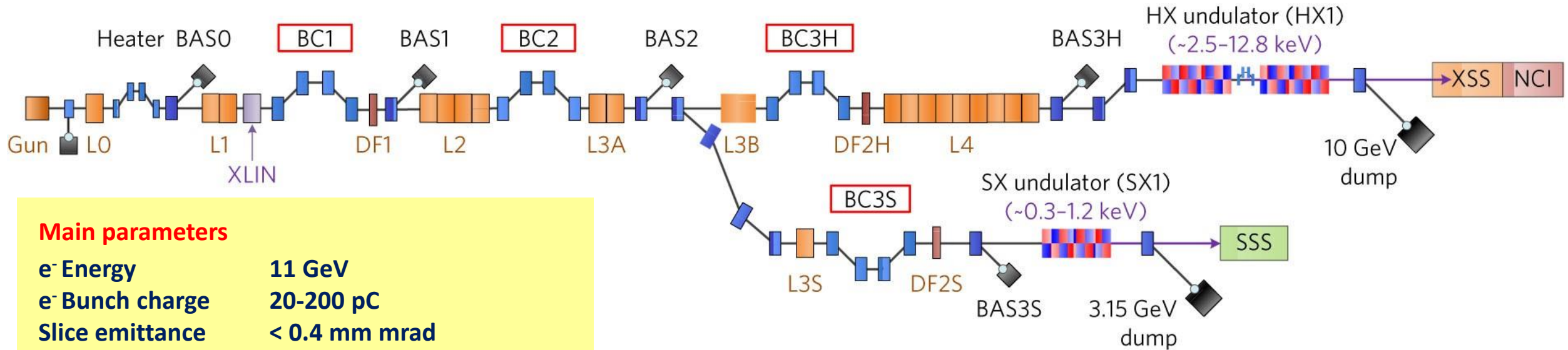
2019: 160 days for user (96.8% of availability)

2020: 170 days for user (96.9% of availability)

2021: 180 days for user (96.9% of availability)

2022: 190 days for user (97.0% of availability)

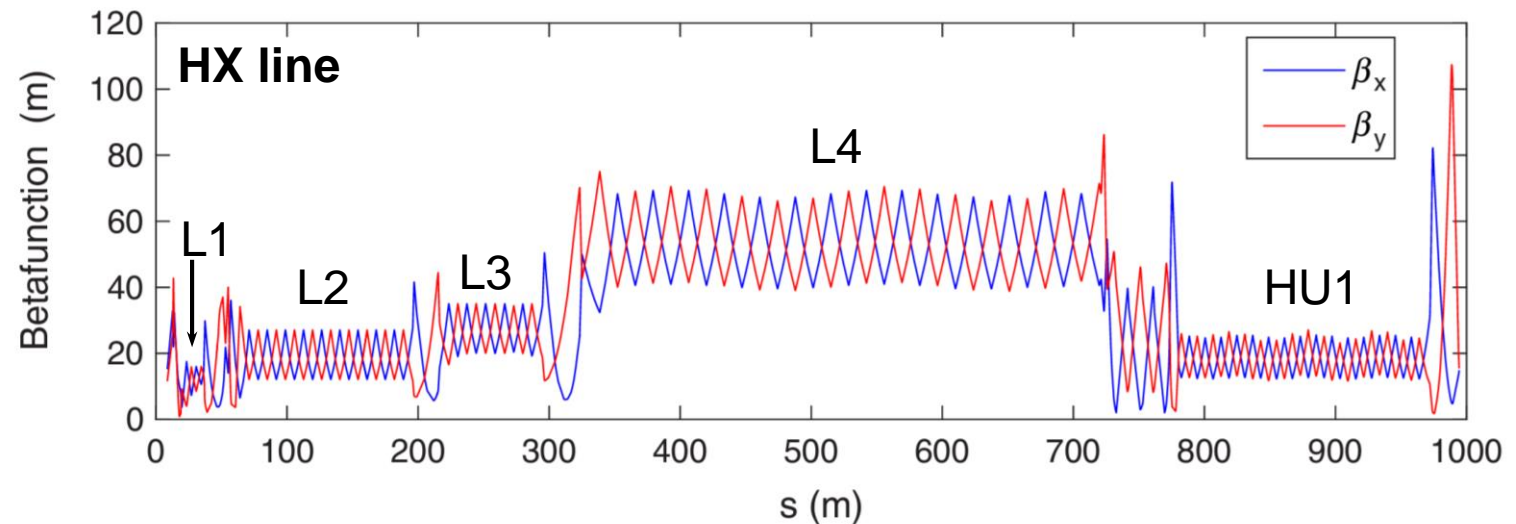
PAL-XFEL Layout & Parameters



Main parameters

e⁻ Energy	11 GeV
e⁻ Bunch charge	20-200 pC
Slice emittance	< 0.4 mm mrad
Repetition rate	60 Hz
Bunch length	5 fs – 50 fs
Peak current	3 kA
SX line switching	Kicker Magnet

Undulator Line	HX	SX
Photon energy [keV]	2.0 ~ 15.0	0.25 ~ 1.25
Beam Energy [GeV]	4 ~ 11	3.0
Wavelength Tuning	Energy	Gap
Undulator Type	Planar	Planar
Und. Period / Gap [mm]	26 / 8.3	35 / 9.0



Procedure of beam-based optimization

✓ Uncompressed beam (on-crest acceleration)

- ✓ Undulator beam-based alignment with different beam energies [~2h]
- ✓ Undulator vertical offset alignment (Undulator field center) [~30m]
- ✓ Undulator gap alignment (K tuning) [~30 m]

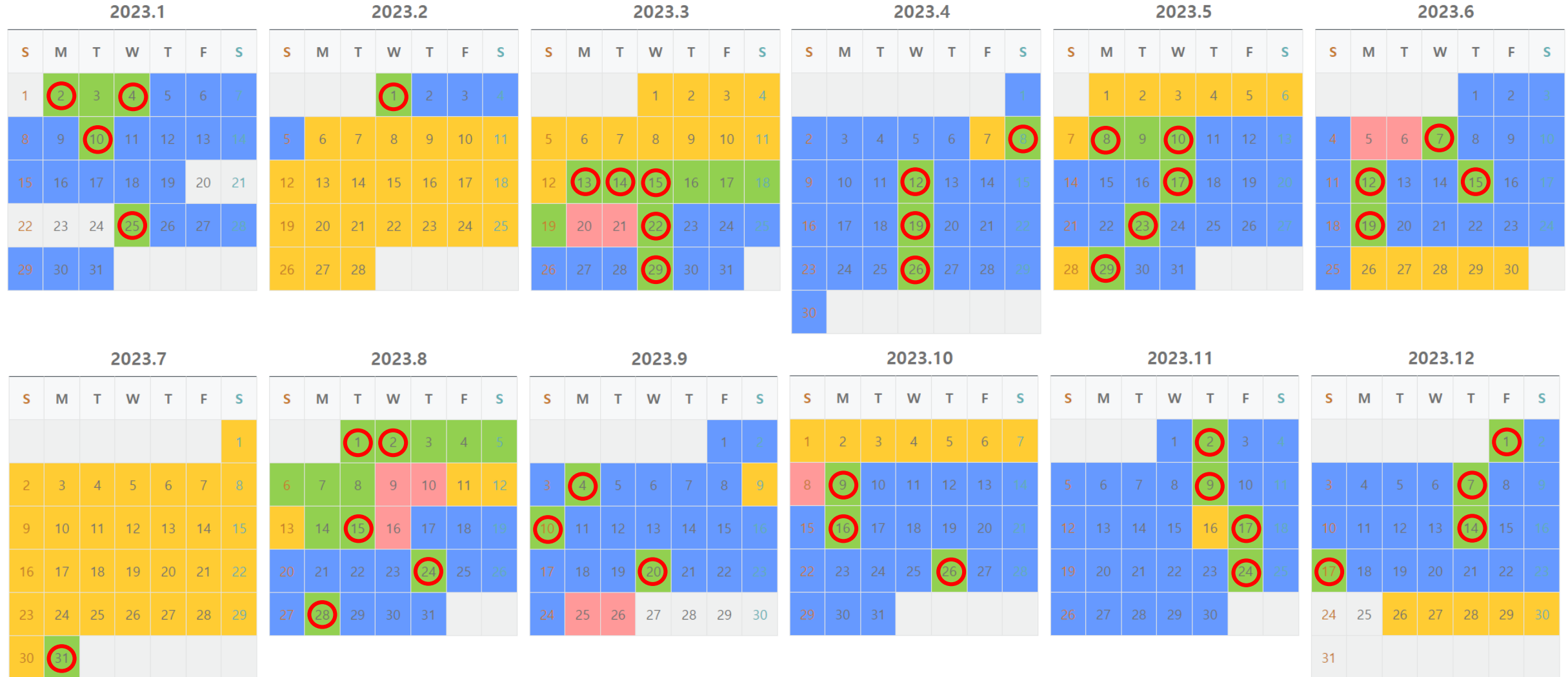
✓ Compressed beam (off-crest acceleration)

- ✓ Preparing initial setting for specific photon energy [~1h]

$$\lambda_r = \frac{\lambda_u}{2\gamma^2} \left(1 + \frac{K^2}{2} \right)$$

- ✓ Laser for photocathode gun, beam energy, magnet PS, rf phase, BC1 collimator
- ✓ Lattice matching for linac and undulator line [~2h]
- ✓ Undulator tapering [~30m]
- ✓ Phase shifter gap tuning [~30m]

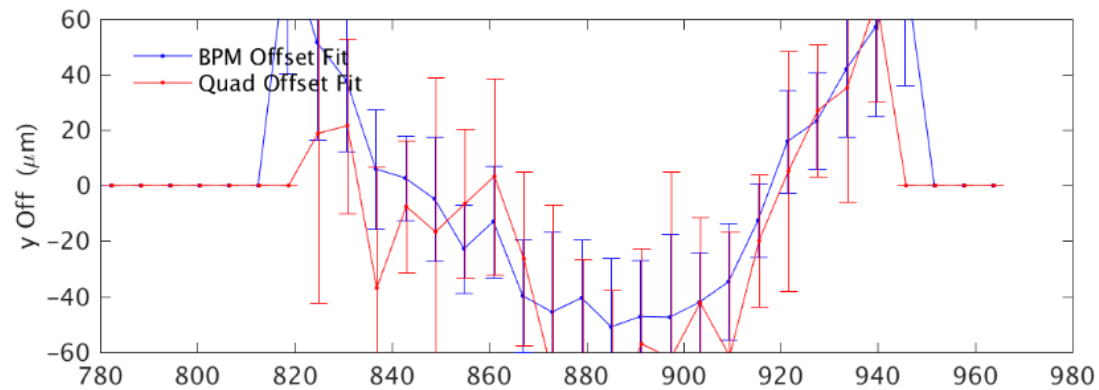
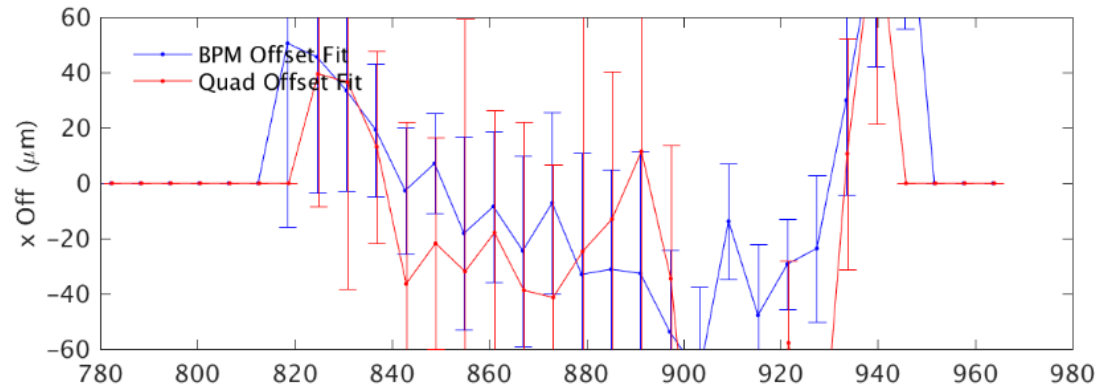
PAL-XFEL operation schedule



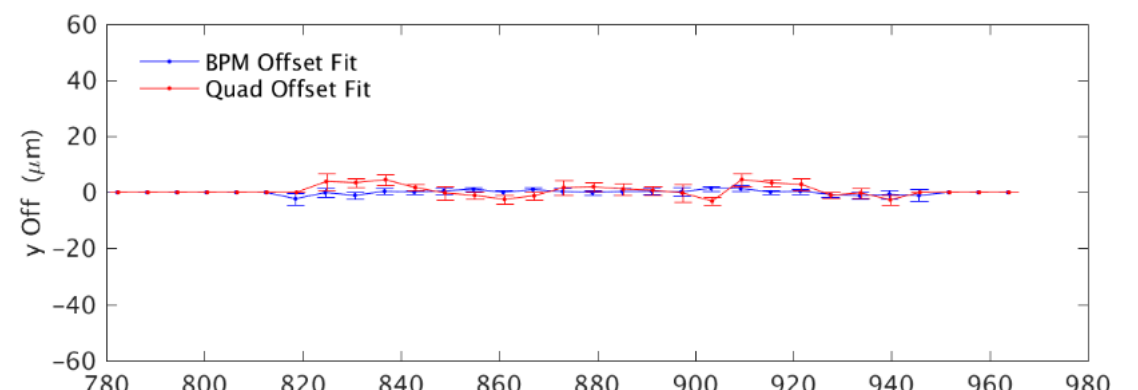
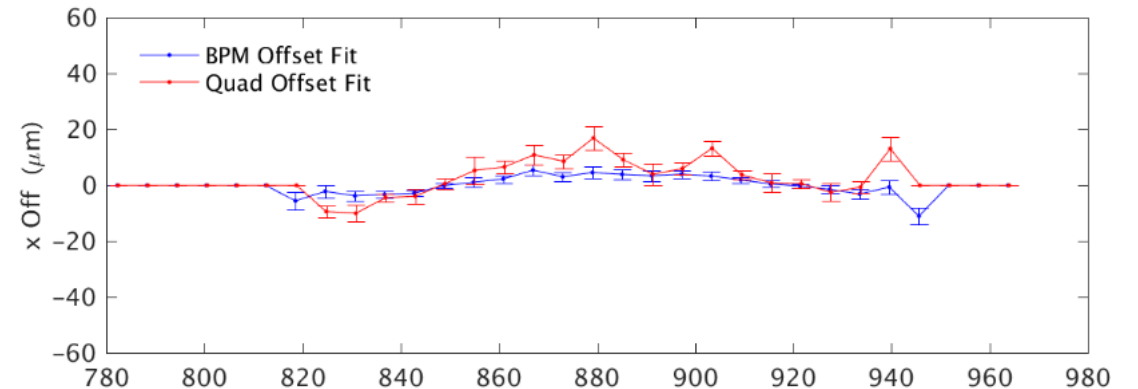
Beam-based optimization process is always performed after the end of maintenance and before the start of user beam time.

Undulator beam-based alignment

Initial condition

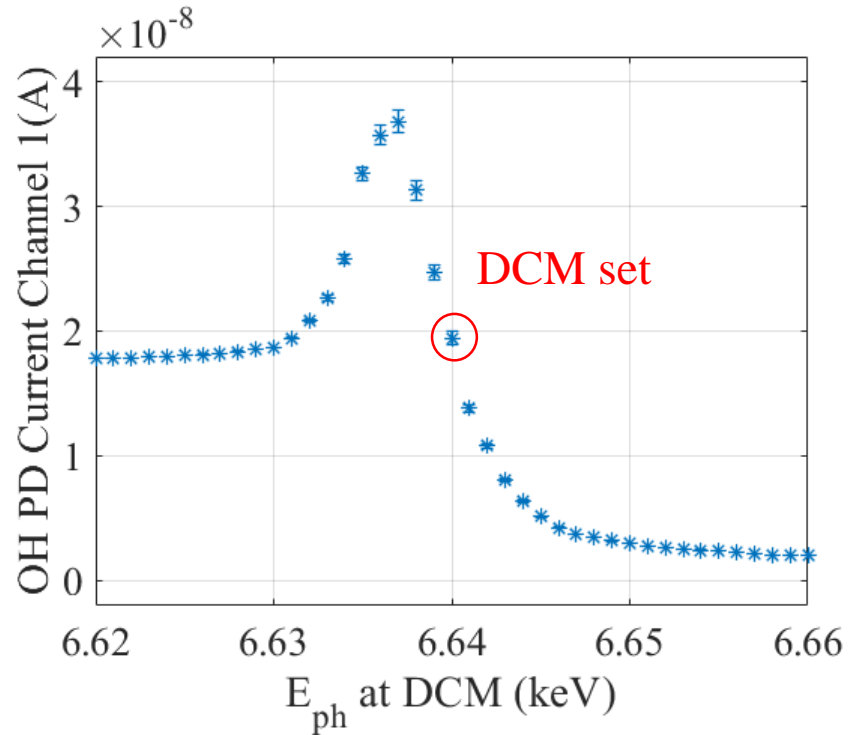


Final condition

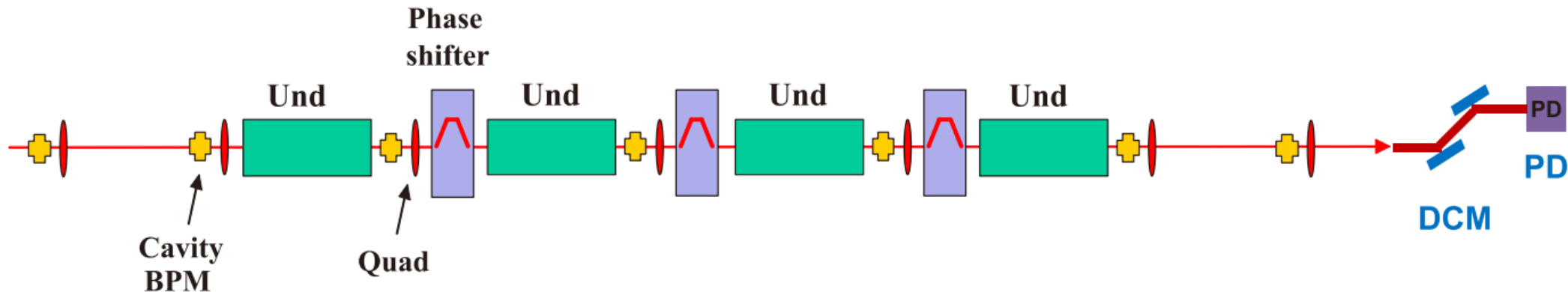


Dispersion-free orbit can be established by changing the BPM offset and QUAD mover offset

Spectrum of radiation for undulator optimization

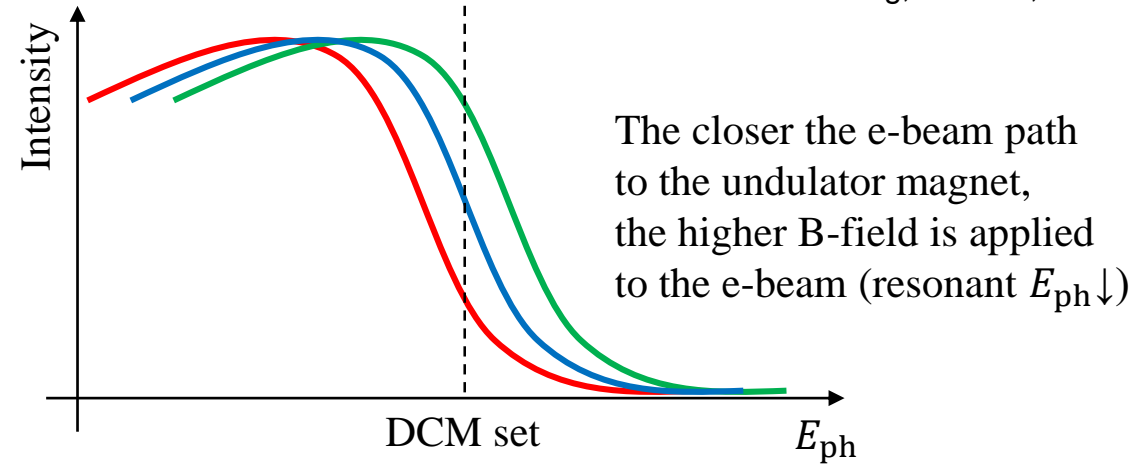
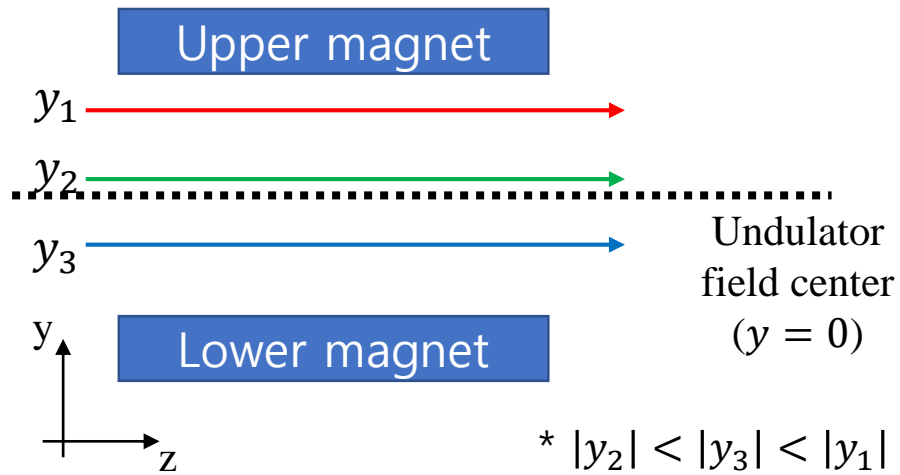


- ✓ Uncompressed electron beam is used to minimize correlated energy spread.
- ✓ Spectrum of the radiation has to be measured to set the photon energy at the monochromator.
- ✓ Photon energy at the monochromator (DCM for HX) is selected at which the signal of detector is sensitively changed.

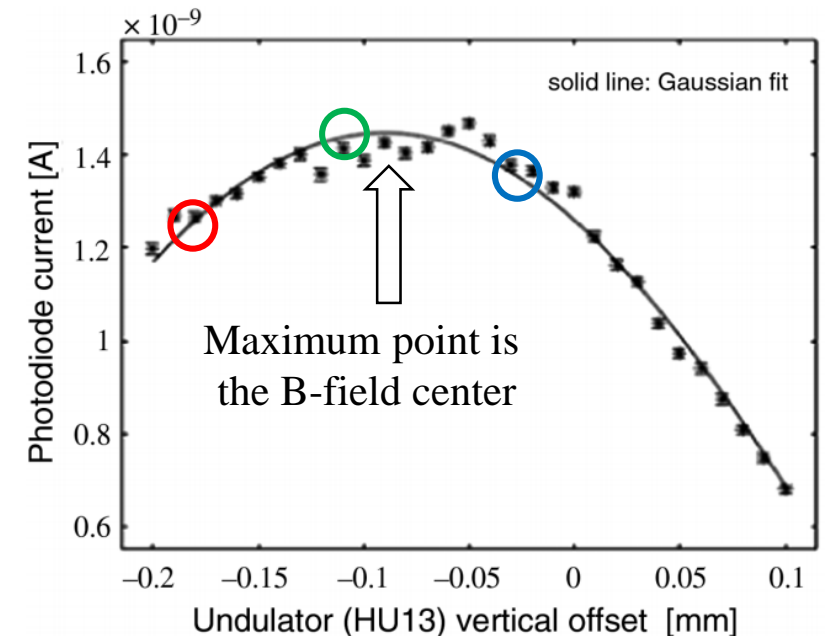
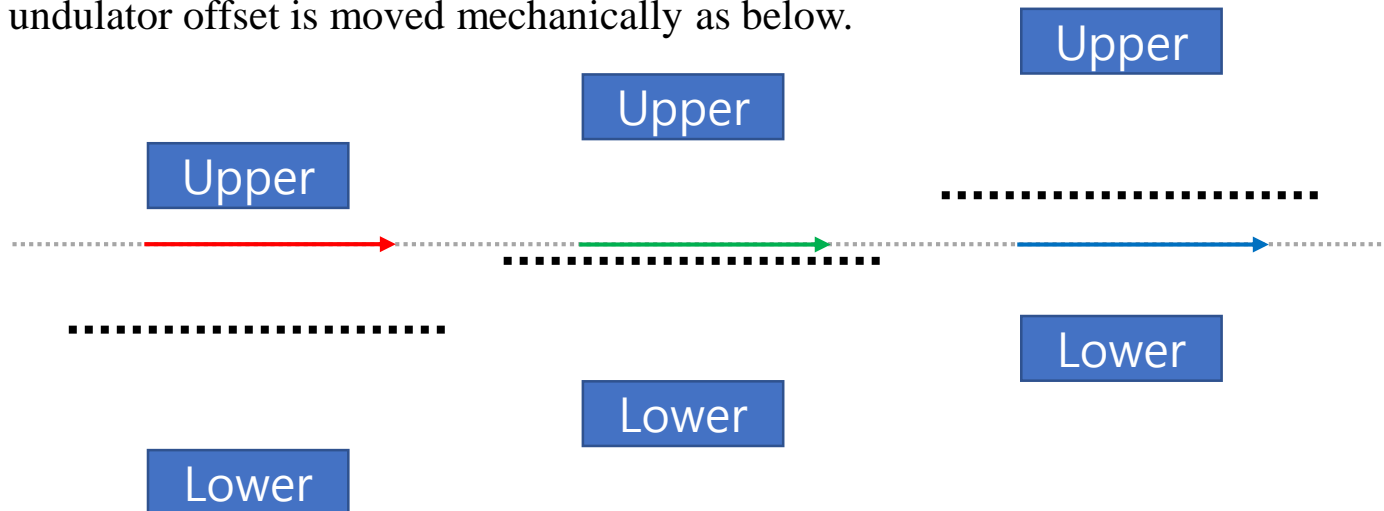


Undulator vertical offset scan to find B-field center

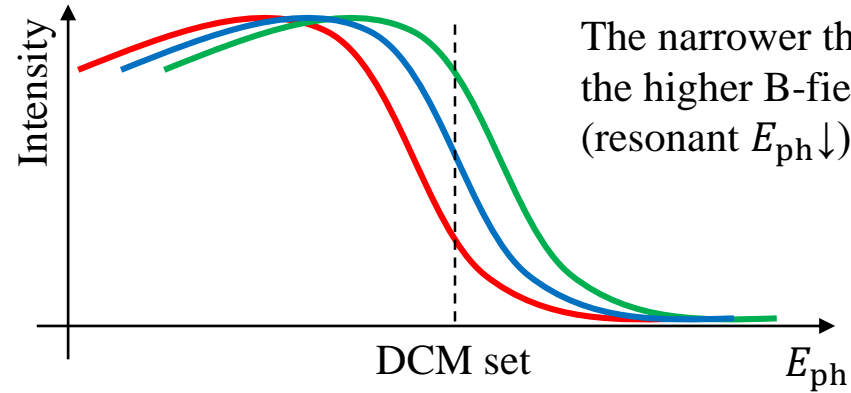
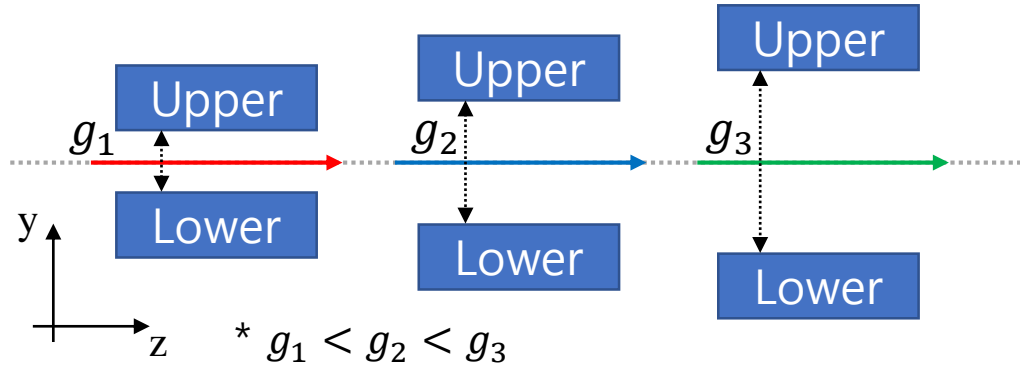
T. Tanaka *et al.*, PRAB **15**, 110701 (2012)
H.-S. Kang, H. Loos, PRAB **22** 060703 (2019)



In the Exp. \rightarrow electron beam path is fixed and undulator offset is moved mechanically as below.



Undulator K-tuning to match same B-field

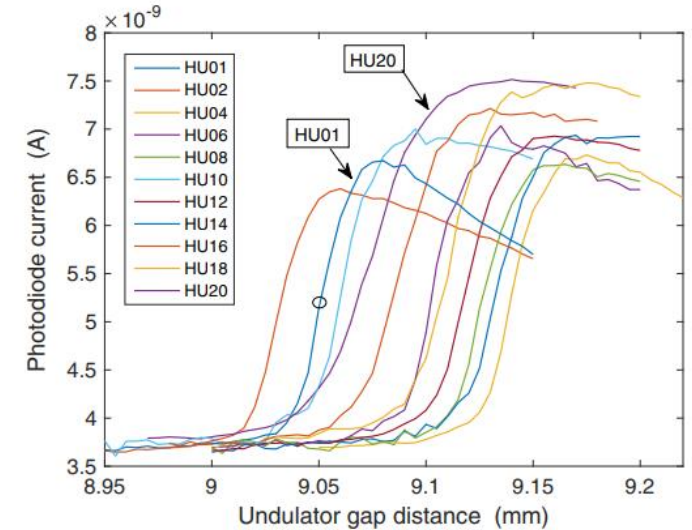
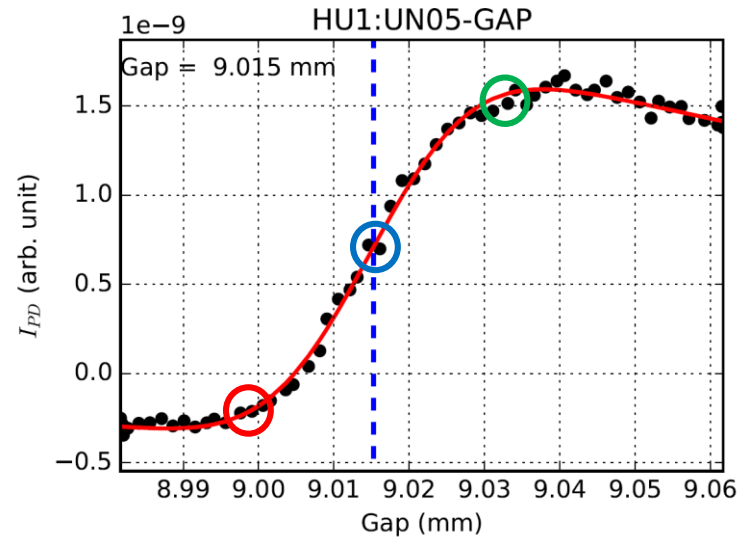


In the Exp.

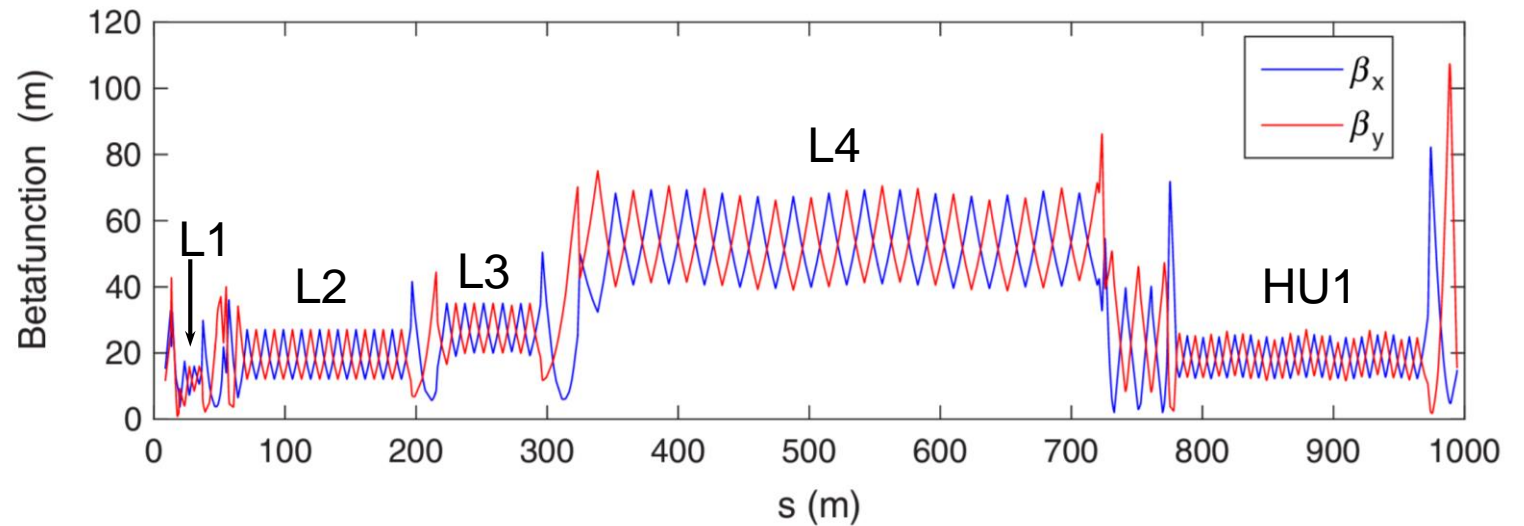
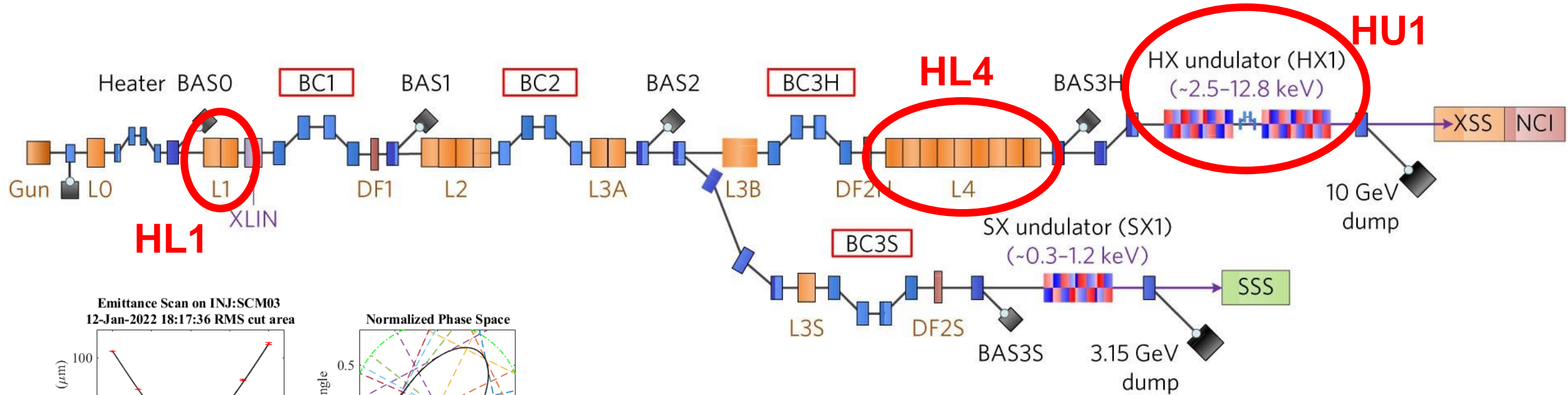
→ electron beam path is fixed
and undulator gap is moved.

$$f(g) = [a_1 + a_4(g - a_2)] \operatorname{erf}\left(-\frac{g - a_2}{a_3}\right) + a_5 + a_6g$$

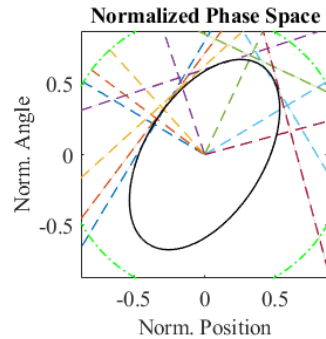
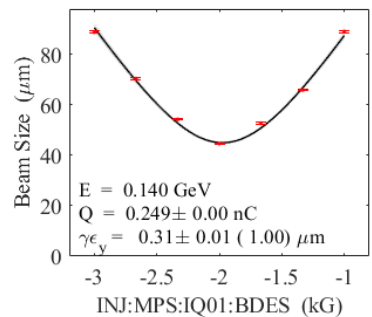
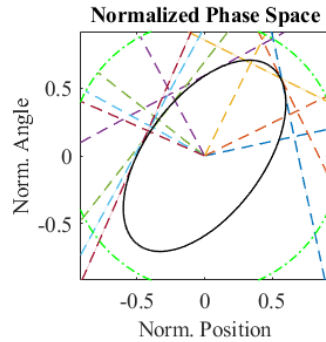
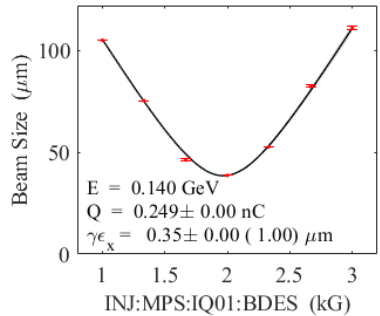
a_2 is the determined gap distance
by fitting with the error function



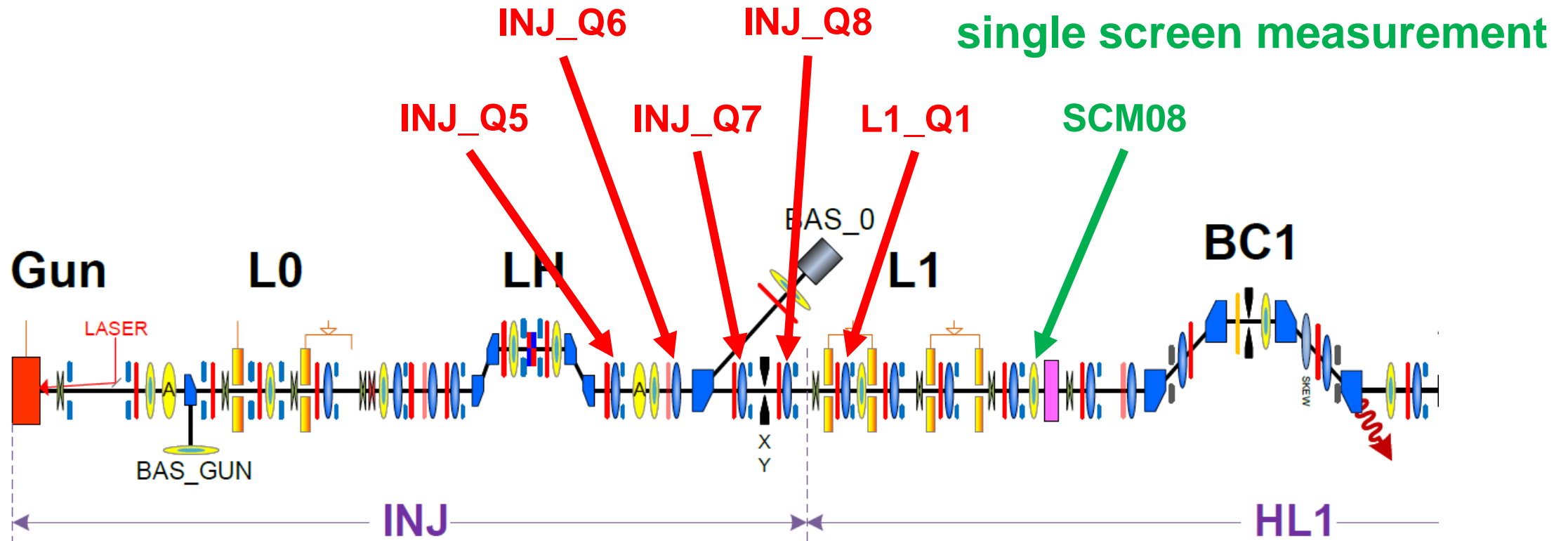
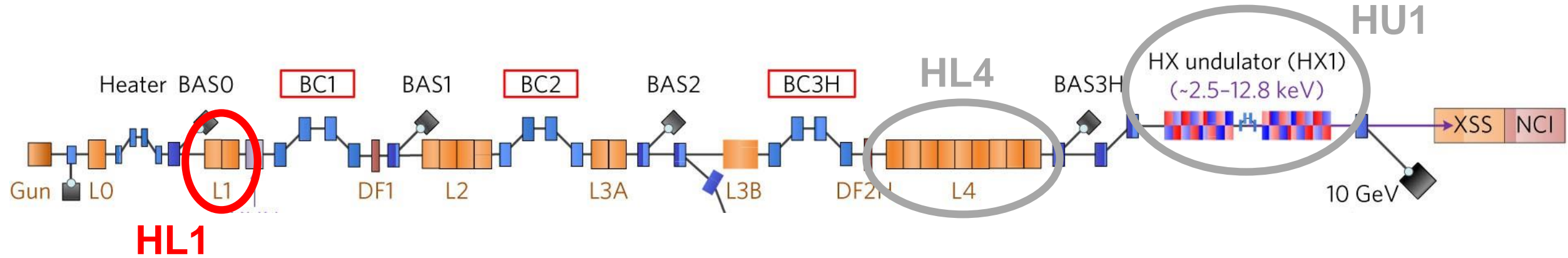
Lattice matching sections at PAL-XFEL



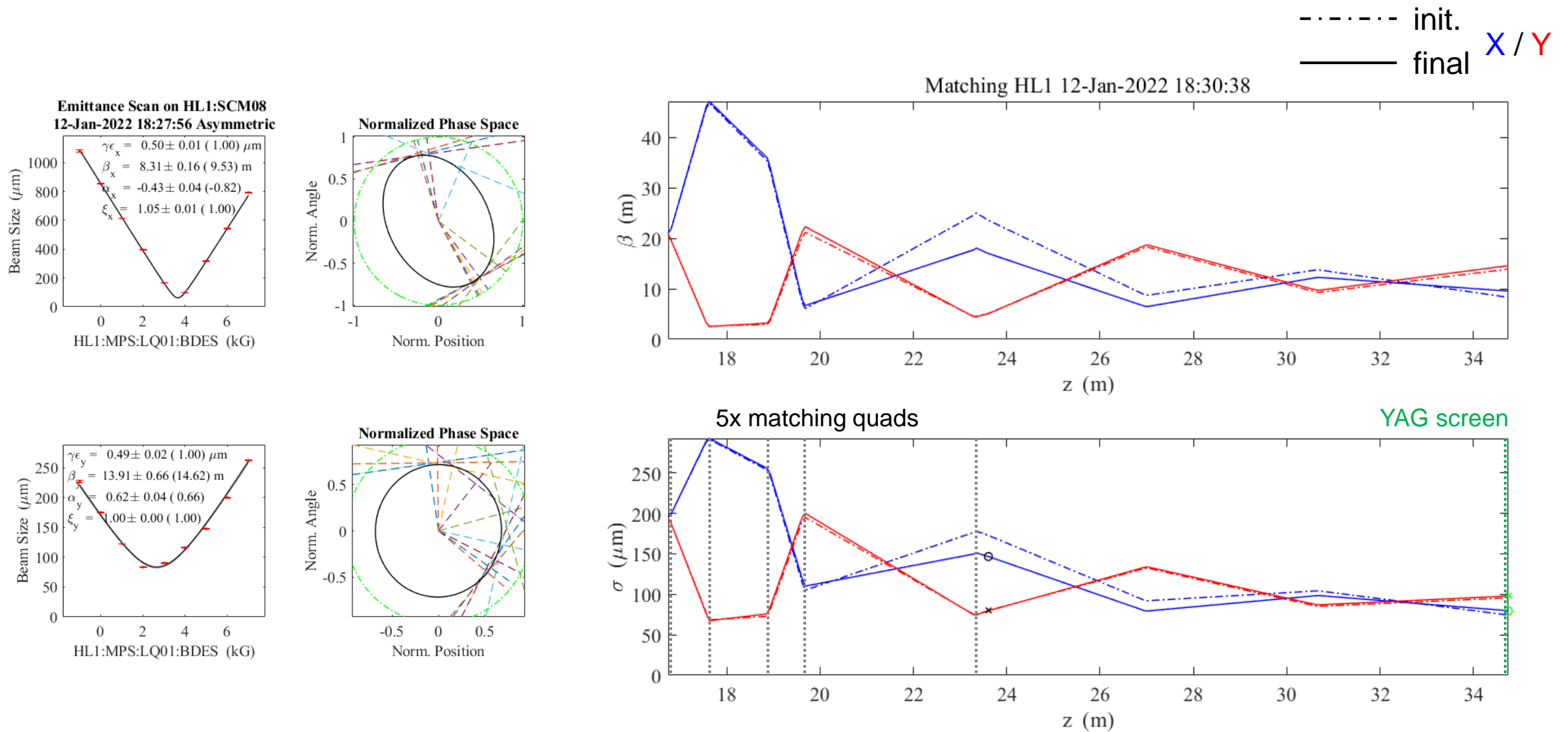
Emittance Scan on INJ:SCM03
12-Jan-2022 18:17:36 RMS cut area



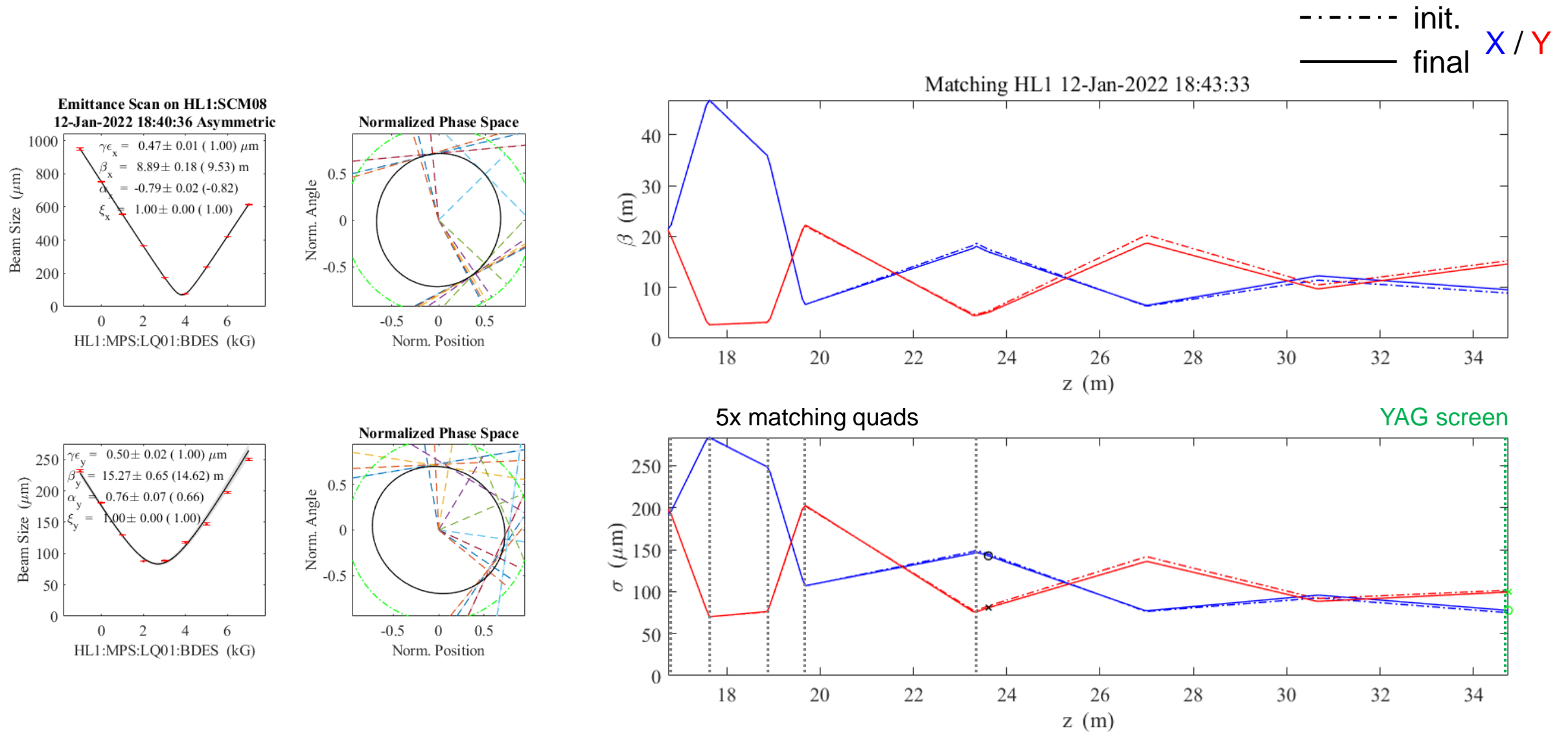
Lattice matching for HL1



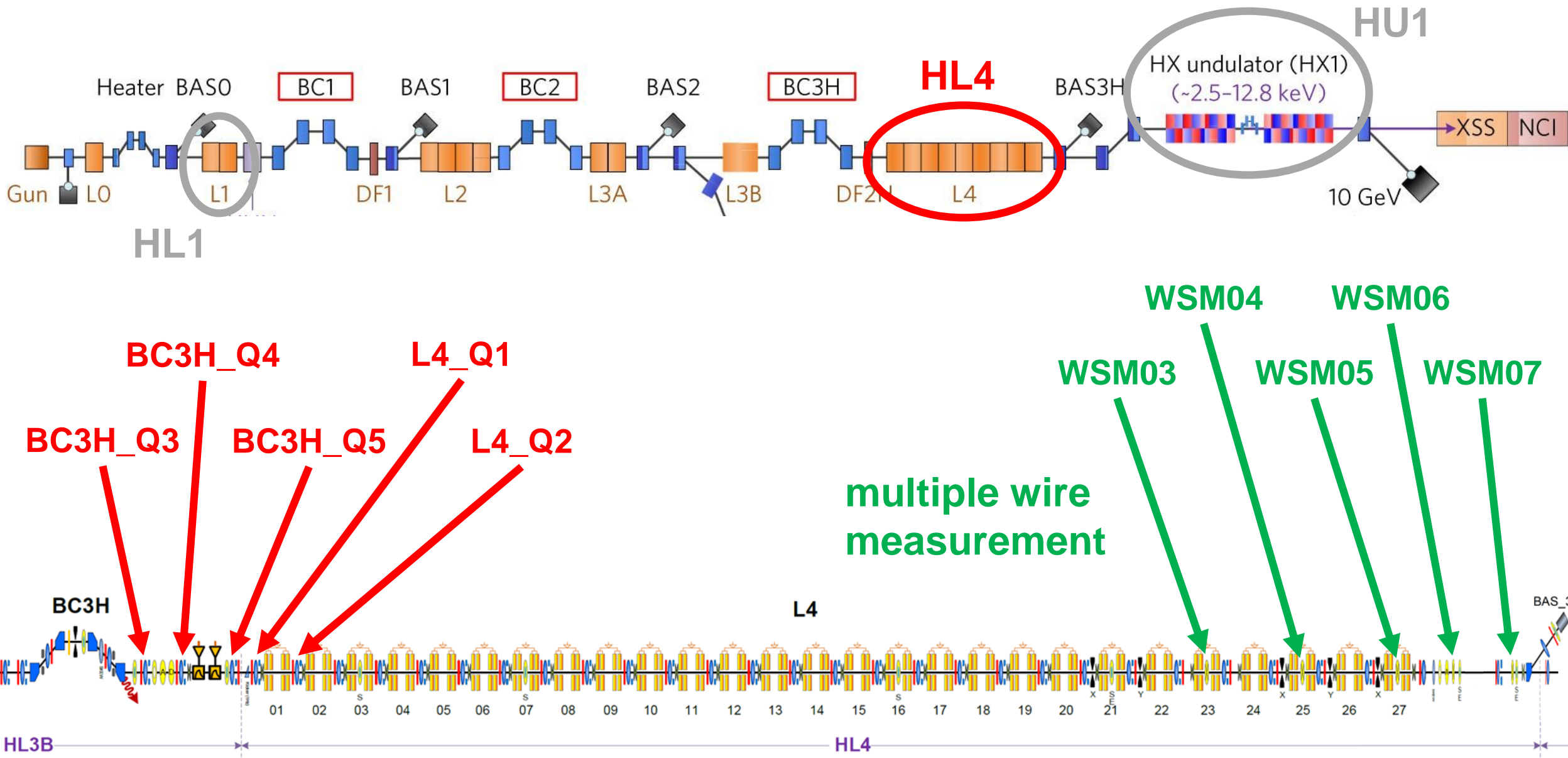
Lattice matching for HL1 (before)



Lattice matching for HL1 (after)

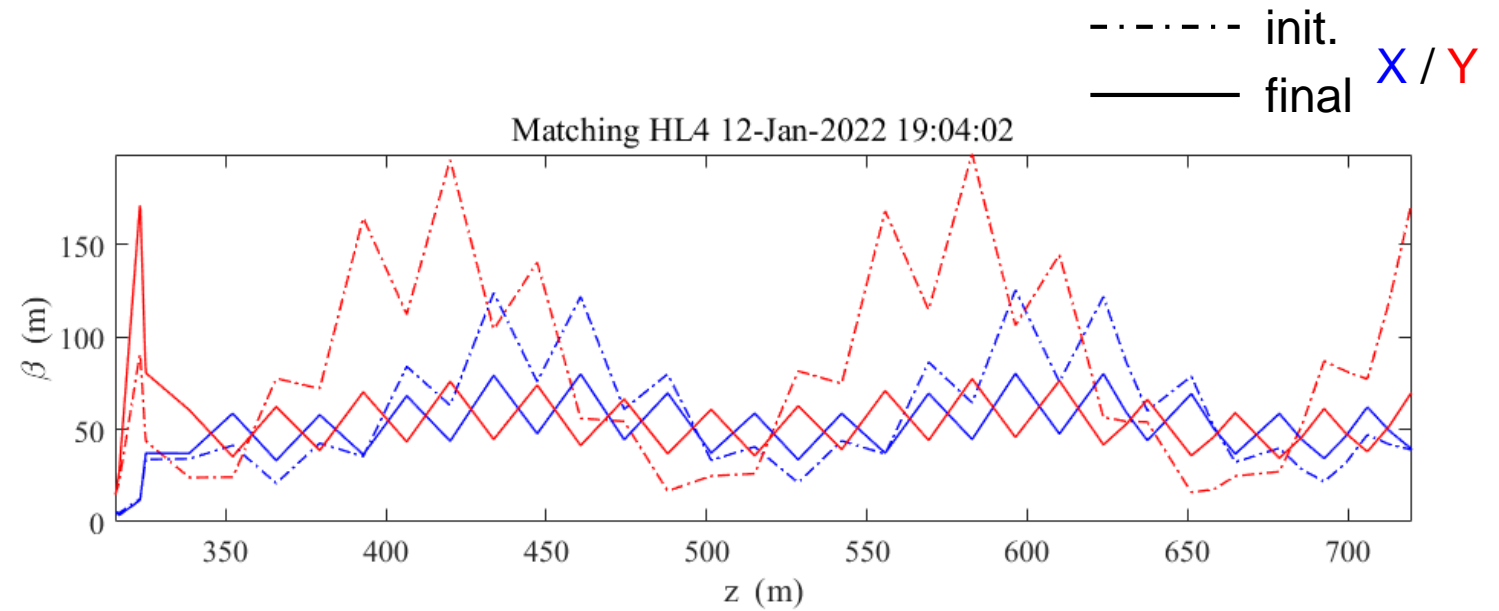
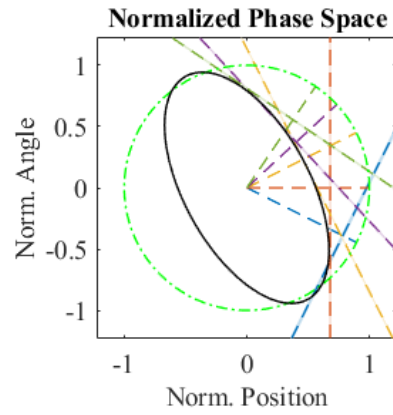
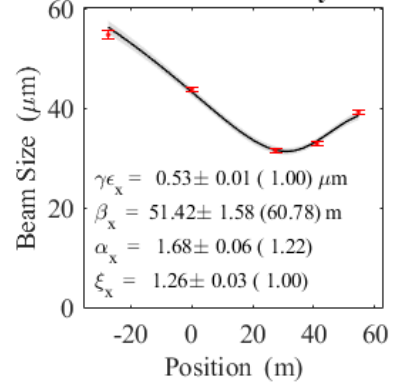


Lattice matching for HL4

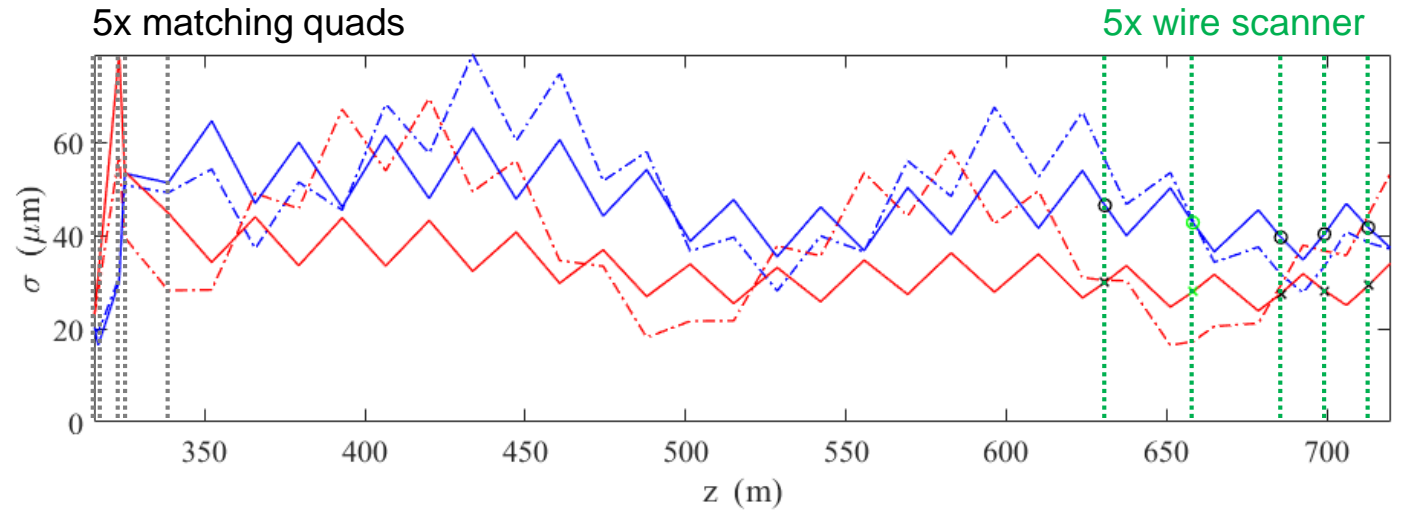
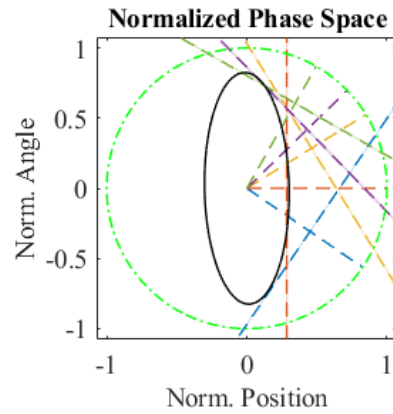
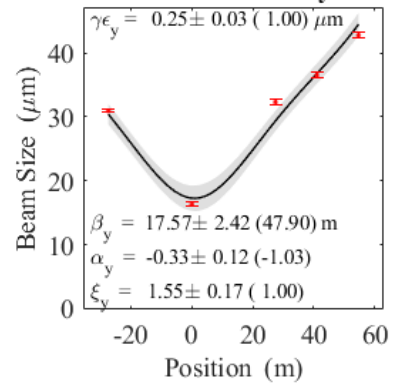


Lattice matching for HL4 (before)

Emittance Scan on HL4:WSM04
12-Jan-2022 18:55:40 Asymmetric

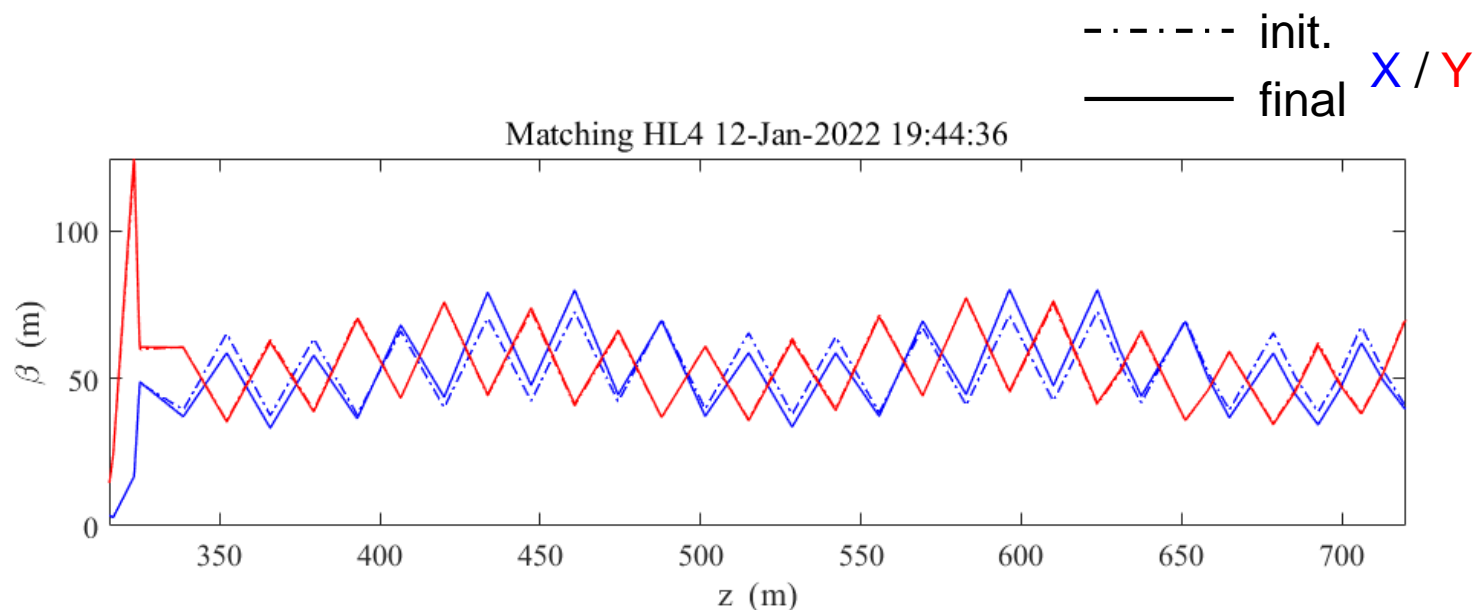
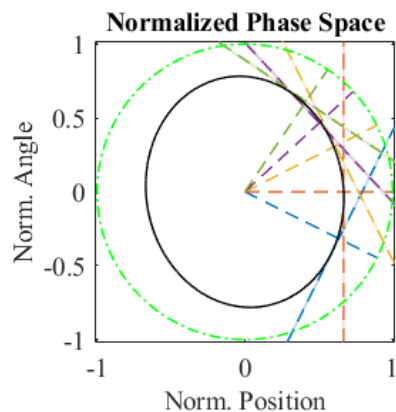
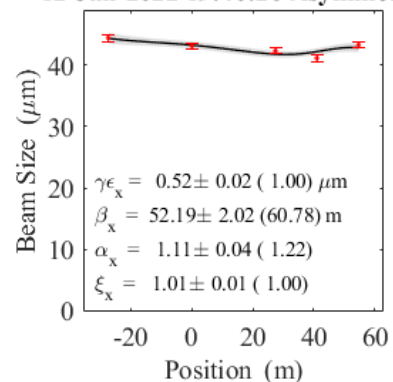


Emittance Scan on HL4:WSM04
12-Jan-2022 19:01:23 Asymmetric

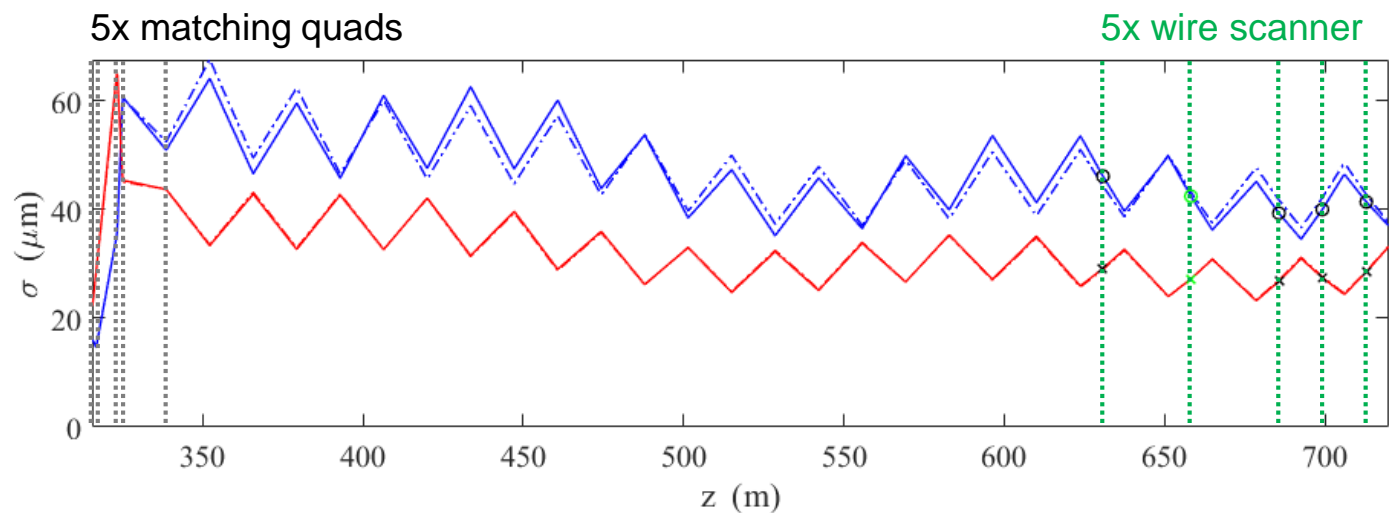
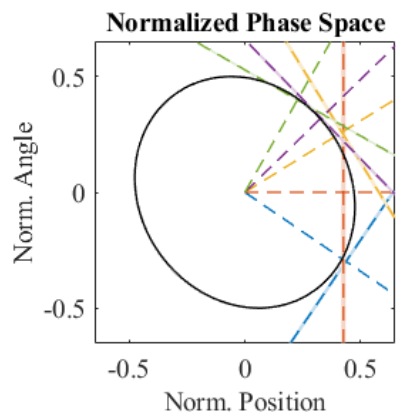
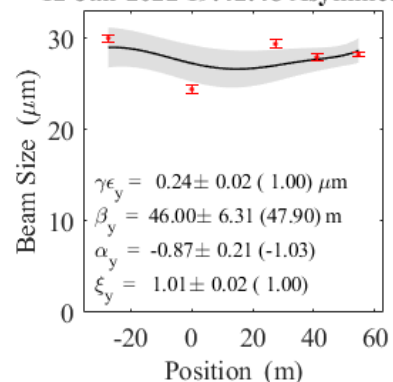


Lattice matching for HL4 (after)

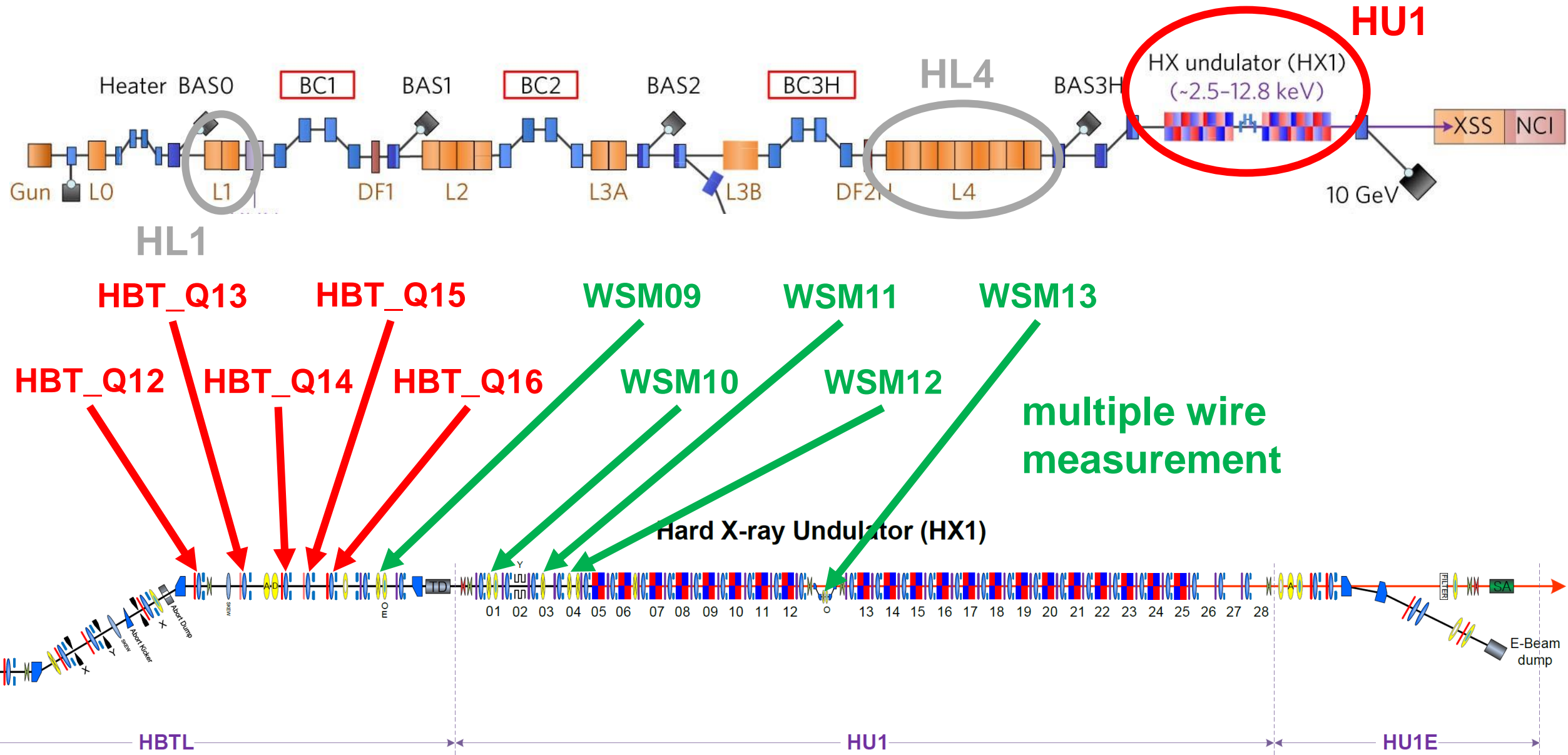
Emittance Scan on HL4:WSM04
12-Jan-2022 19:40:20 Asymmetric



Emittance Scan on HL4:WSM04
12-Jan-2022 19:42:48 Asymmetric

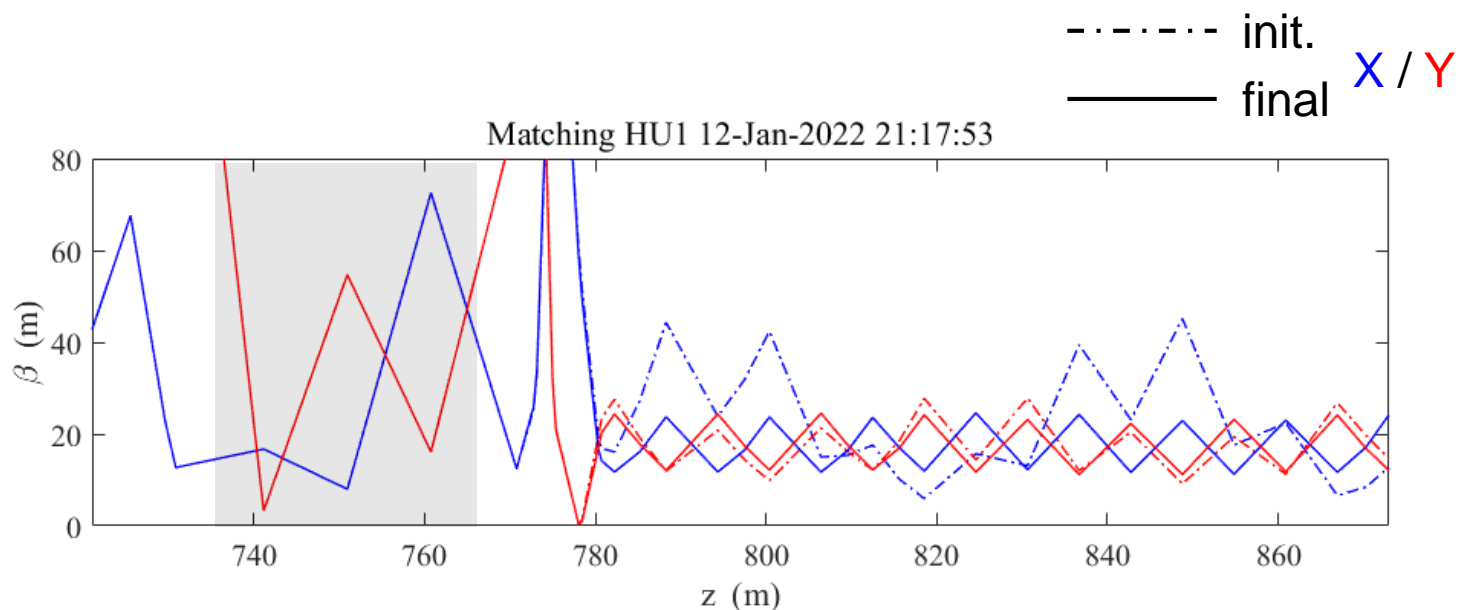
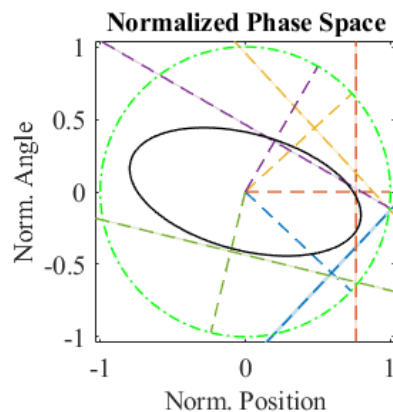
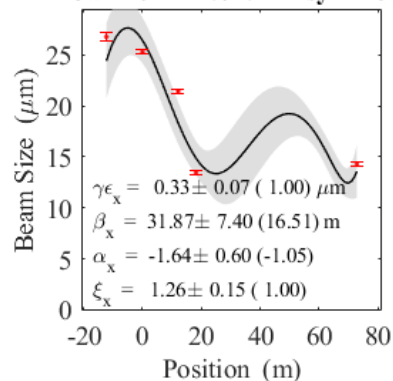


Lattice matching for HU1

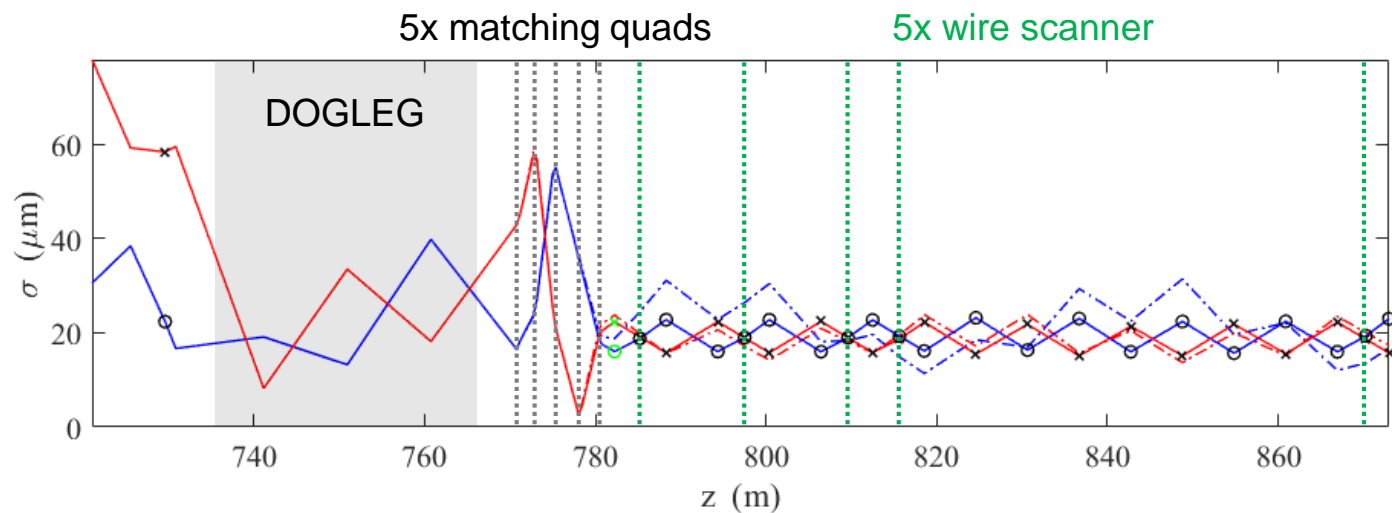
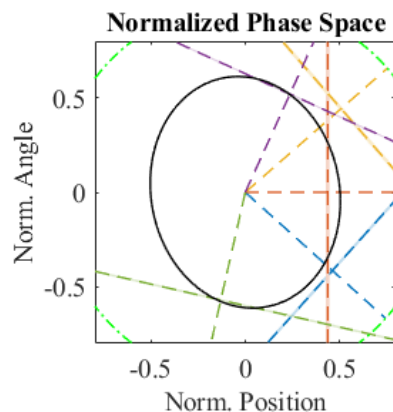
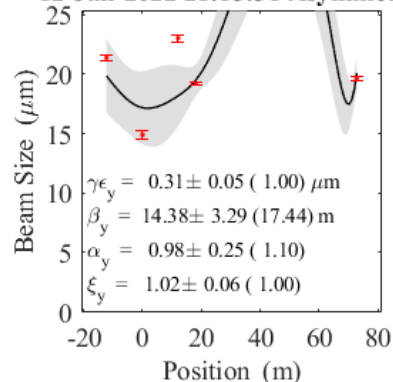


Lattice matching for HU1 (before)

Emittance Scan on HU1:WSM10
12-Jan-2022 21:04:42 Asymmetric

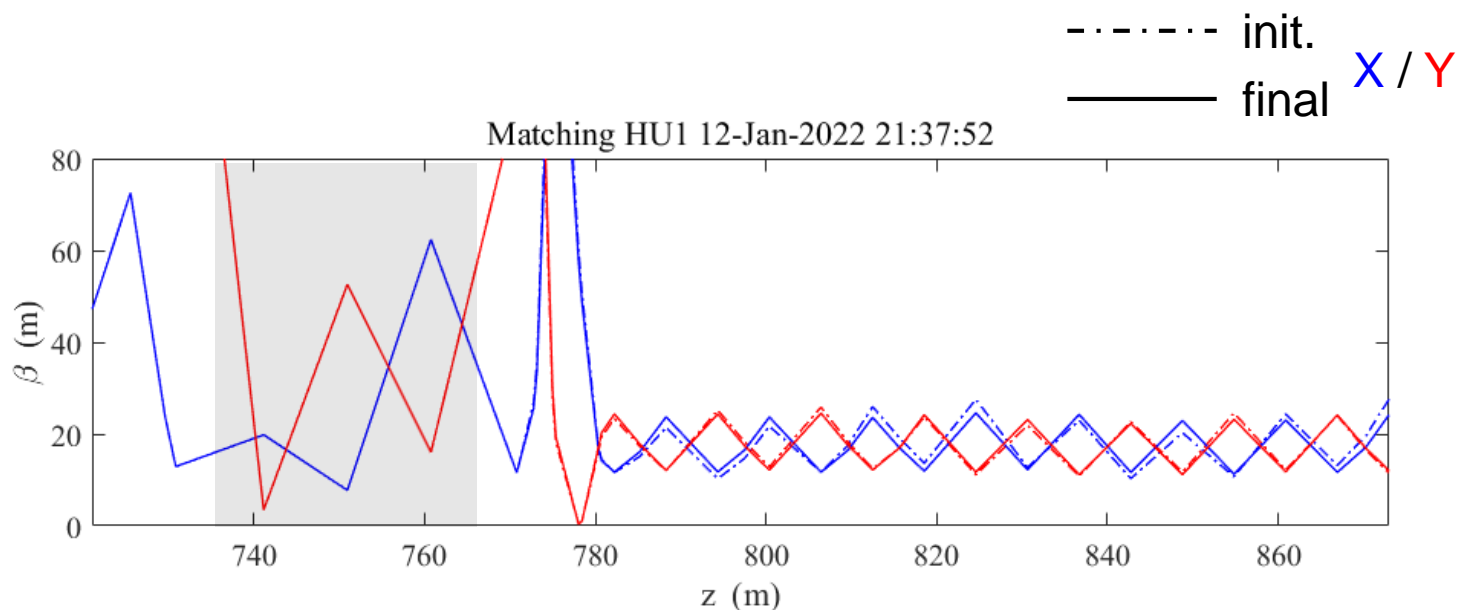
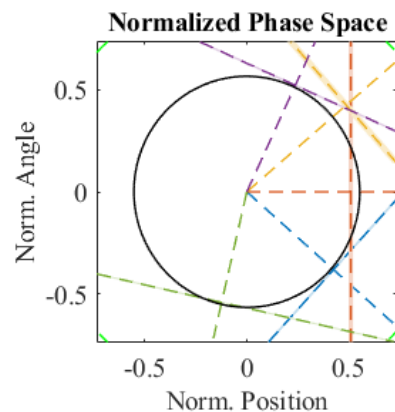
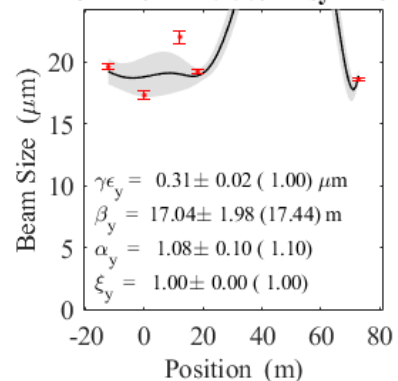


Emittance Scan on HU1:WSM10
12-Jan-2022 21:15:31 Asymmetric

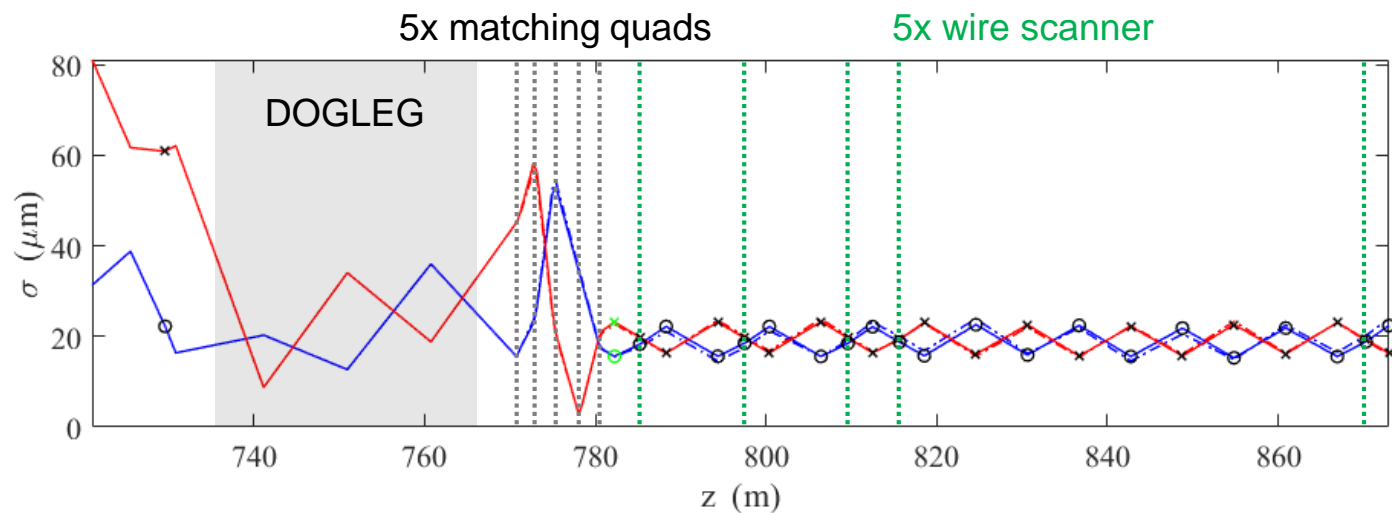
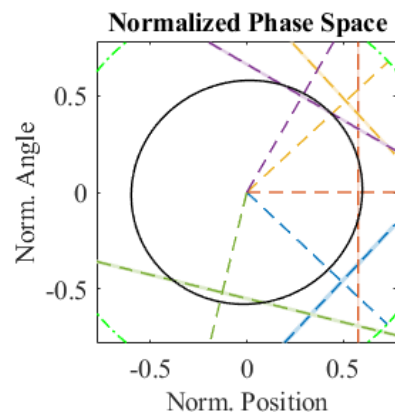
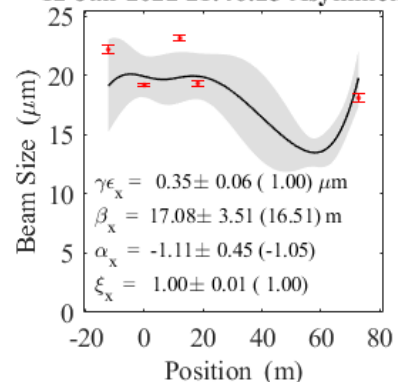


Lattice matching for HU1 (after)

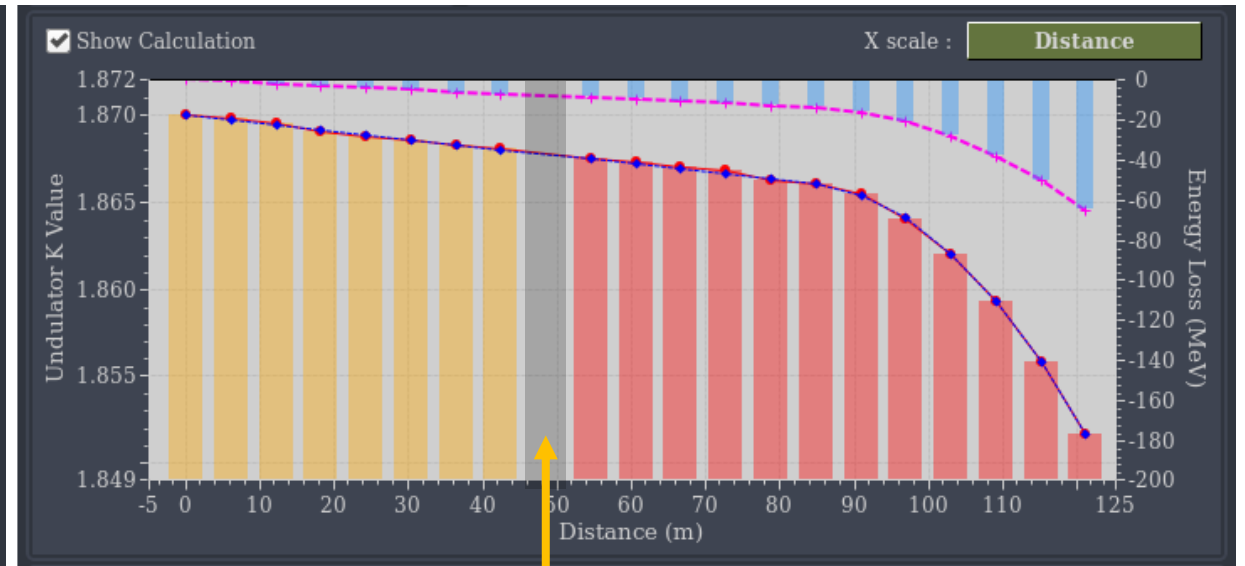
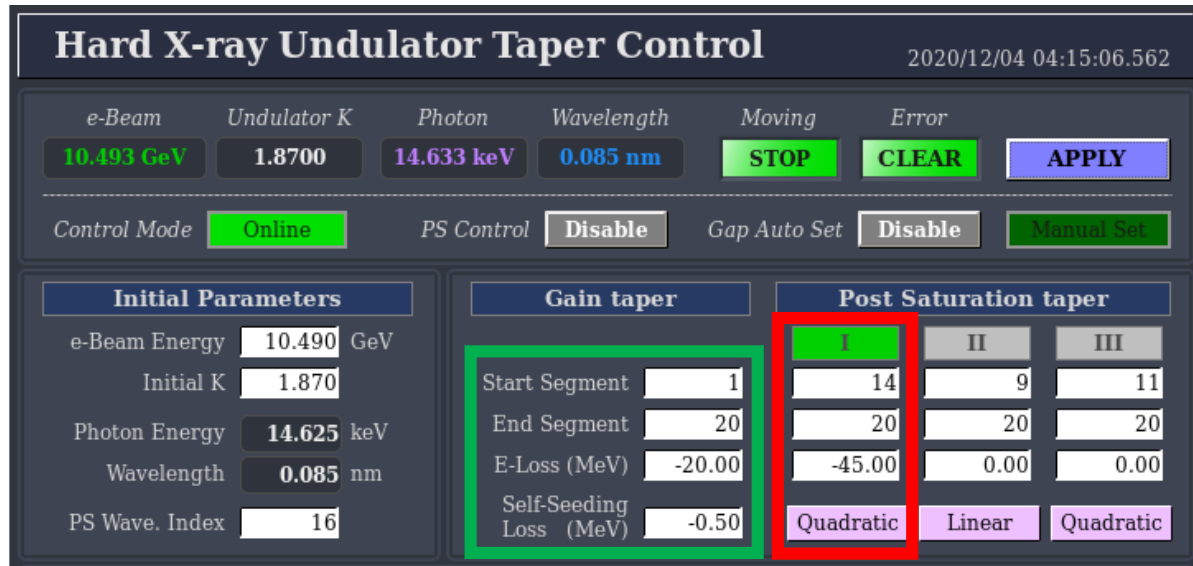
Emittance Scan on HU1:WSM10
12-Jan-2022 21:49:04 Asymmetric



Emittance Scan on HU1:WSM10
12-Jan-2022 21:46:23 Asymmetric



Undulator tapering

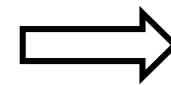


energy loss due to the resistive wakefield effect → linear

energy loss due to the FEL lasing → quadratic

Electron beam energy at the i-th undulator

$$\begin{cases} E_i = E_{\text{init}} + \frac{\Delta E_{\text{linear}}}{N_{\text{tot}}} \cdot i & (i < n_{\text{quad},\text{start}}) \\ E_i = E_{\text{init}} + \frac{\Delta E_{\text{linear}}}{N_{\text{tot}}} \cdot i + \frac{\Delta E_{\text{quadratic}}}{(N_{\text{tot}} - n_{\text{quad},\text{start}})^2} \cdot (i - n_{\text{quad},\text{start}})^2 & (i \geq n_{\text{quad},\text{start}}) \end{cases}$$



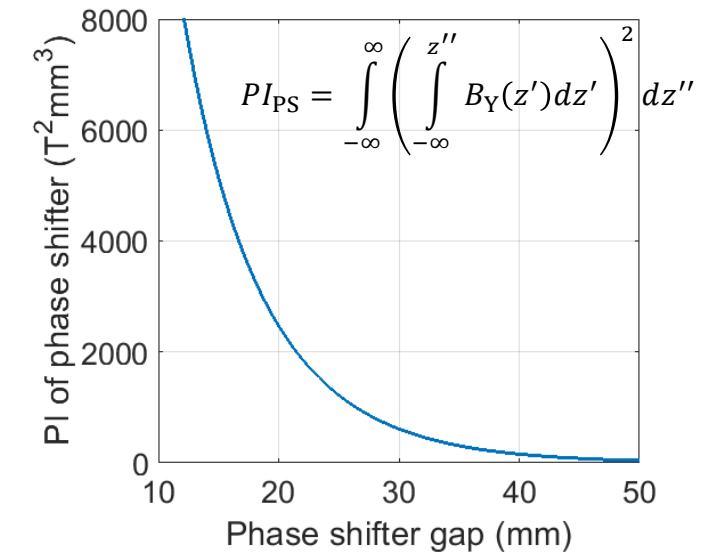
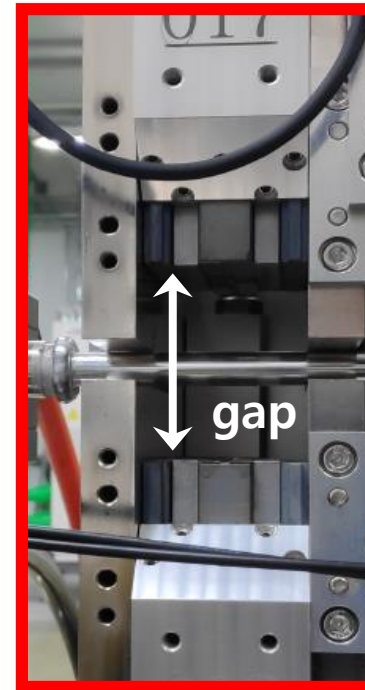
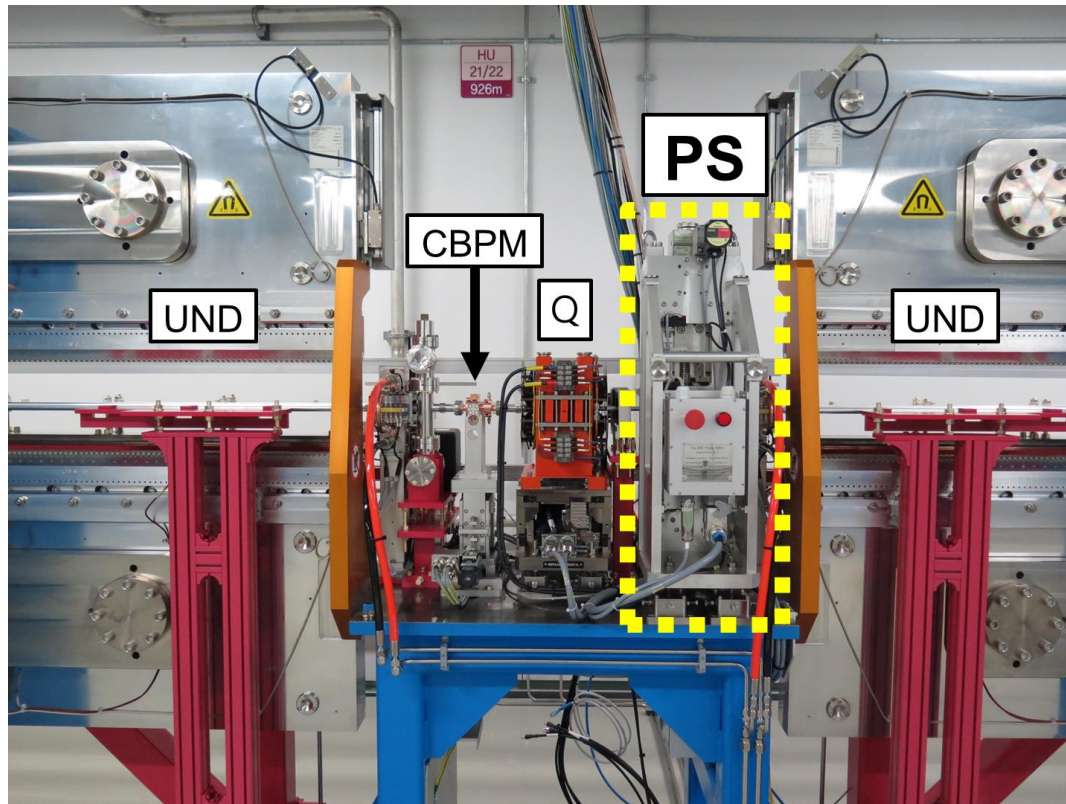
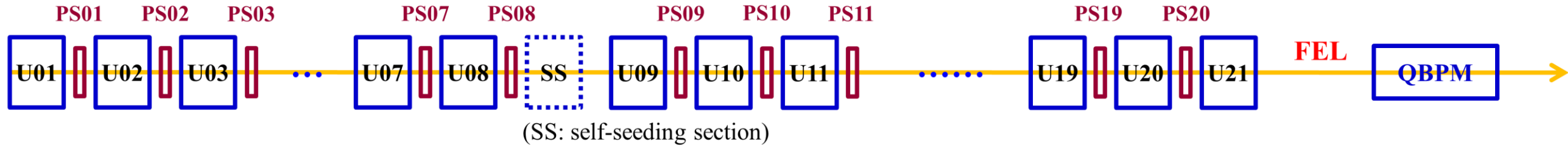
Resonance condition

$$K = \sqrt{2 \cdot \left(\frac{2\gamma^2 \lambda_r}{\lambda_u} - 1 \right)}$$

Examples of undulator tapering



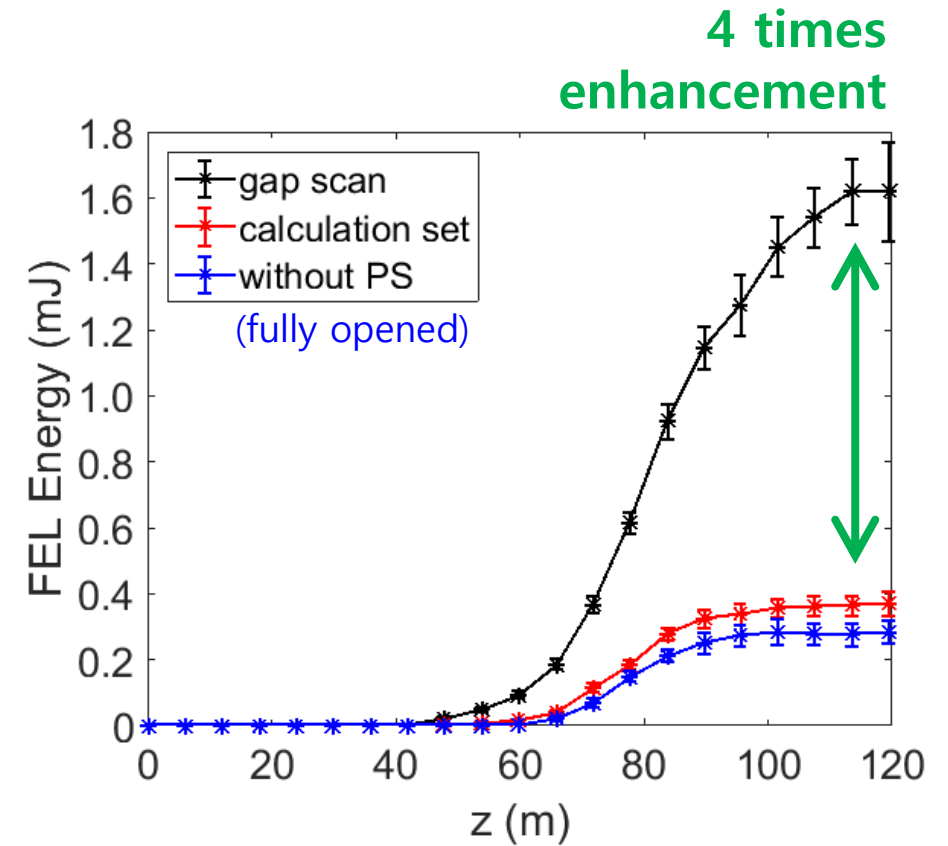
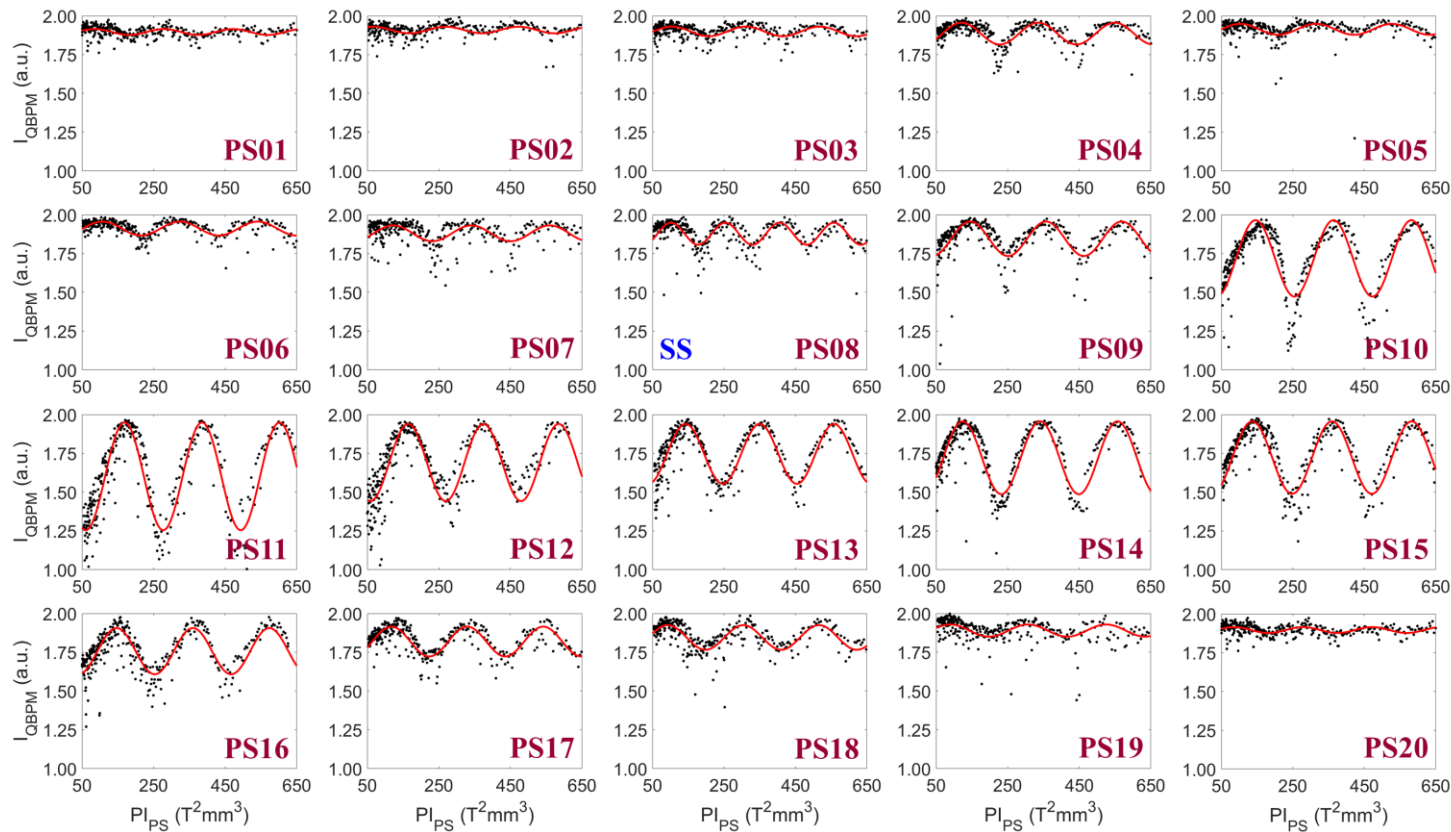
Phase shifter between undulators



$$s = \frac{1}{2\gamma^2} \left(L_{int} + \left(\frac{e}{mc} \right)^2 \cdot PI_{PS} \right) = n \times \lambda_u$$

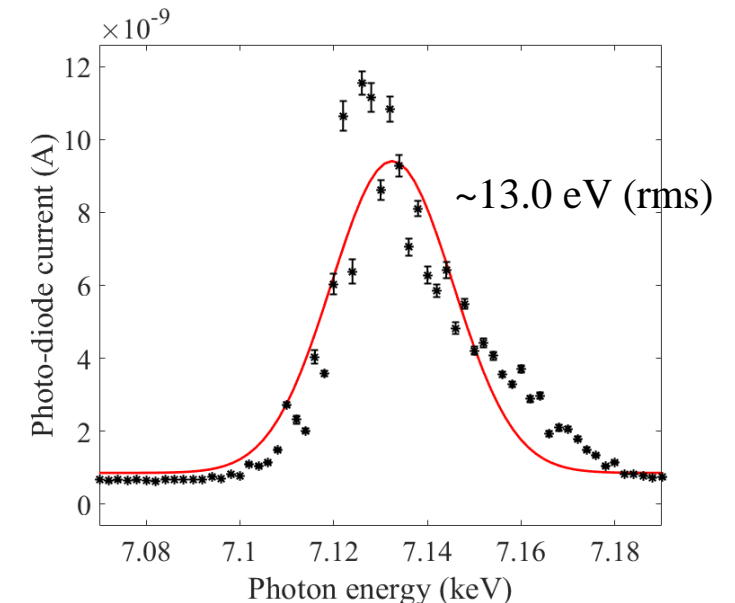
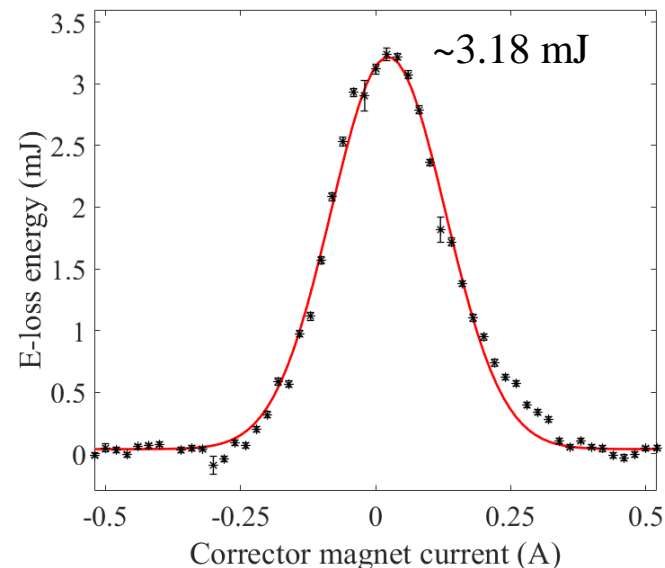
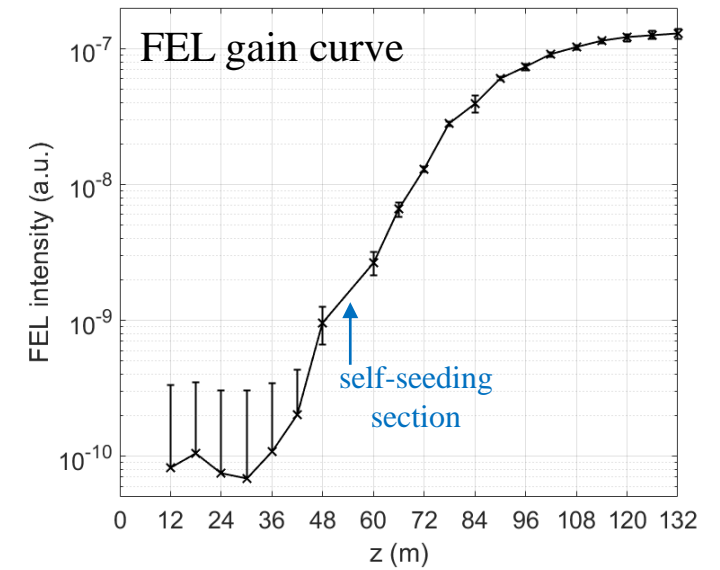
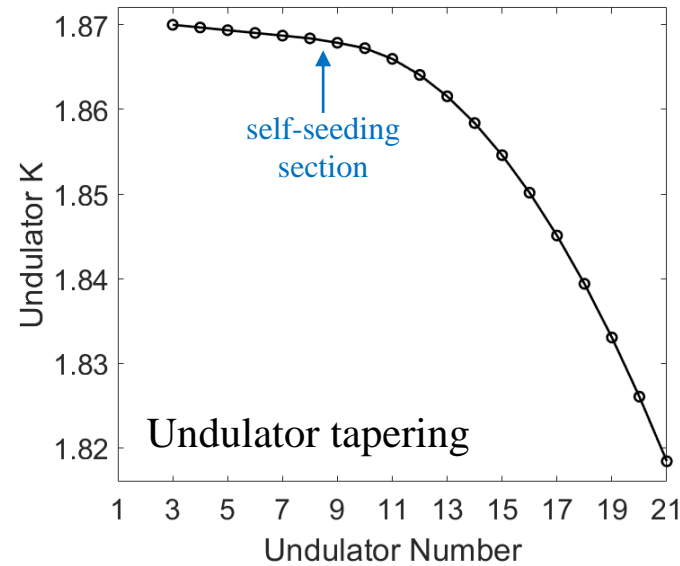
To match the phase between FEL pulse and electron beam

Phase shifter gap tuning results



3.2 mJ at 7.13 keV FEL – Record of highest pulse energy at PAL-XFEL

- ✓ 7.13 keV SASE FEL
- ✓ E_{beam} : 7.325 GeV
- ✓ Norm. emittance at injector:
0.35 μm (hor) / 0.31 μm (ver)
- ✓ Norm. emittance at HU1:
0.35 μm (hor) / 0.31 μm (ver)
- ✓ Peak current: 2.8 kA
- ✓ 19 (6+13) undulators are used to optimize FEL intensity
- ✓ XFEL pulse duration: 36.0 fs (FWHM)
measured by using cross-correlation method
at self-seeding section



Results of FEL tuning for beamtime (2022. 01. 12)

Summary

- ✓ Beam-based optimization process is performed to maximize the FEL intensity after the end of major maintenance in summer/winter and before the start of every user beam time.
- ✓ Alignment process for undulator line (quad. mover position, cavity-bpm offset, undulator vertical offset, undulator gap for identical B field) is carried out by using un-compressed electron beam
- ✓ Lattice matching, undulator tapering, and phase shifter gap scanning are carried out by using compressed electron beam (~ 3 kA)